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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/076,818	02/14/2002	Nikhil V. Kelkar	NSC1P229/P05148	2031
22434	7590 03/31/2004		EXAMINER	
BEYER WEAVER & THOMAS LLP P.O. BOX 778			KIM, PETER B	
	CA 94704-0778		ART UNIT PAPER N	
,			2851	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/076,818	10/076,818 KELKAR ET AL.				
Office Action Summary	Examiner	Art Unit	1			
	Peter B. Kim	2851	pu			
The MAILING DATE of this communication Period for Reply	appears on the cover sheet w	ith the correspondence add	lress			
A SHORTENED STATUTORY PERIOD FOR RETHE MAILING DATE OF THIS COMMUNICATION - Extensions of time may be available under the provisions of 37 CF after SIX (6) MONTHS from the mailing date of this communication - If the period for reply specified above is less than thirty (30) days, - If NO period for reply is specified above, the maximum statutory properties to reply within the set or extended period for reply will, by some any reply received by the Office later than three months after the rearned patent term adjustment. See 37 CFR 1.704(b).	ON. R 1.136(a). In no event, however, may a in. a reply within the statutory minimum of thir eriod will apply and will expire SIX (6) MON statute, cause the application to become Al	reply be timely filed ty (30) days will be considered timely. ITHS from the mailing date of this con BANDONED (35 U.S.C. § 133).	nmunication.			
Status						
1) Responsive to communication(s) filed on <u>6</u>	09 March 2004.					
2a) ☐ This action is FINAL . 2b) ⊠	This action is non-final.					
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims						
4) ☐ Claim(s) 1-3,5-8 and 10-16 is/are pending 4a) Of the above claim(s) is/are with 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-3,5-8 and 10-16 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction as	drawn from consideration.					
Application Papers						
9) The specification is objected to by the Exar	miner.					
10) The drawing(s) filed on is/are: a)	☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.					
Applicant may not request that any objection to	- · ·	` '				
Replacement drawing sheet(s) including the co			• •			
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for form a) All b) Some * c) None of: 1. Certified copies of the priority docum 2. Certified copies of the priority docum 3. Copies of the certified copies of the application from the International But * See the attached detailed Office action for a	nents have been received. nents have been received in A priority documents have been reau (PCT Rule 17.2(a)).	pplication No received in this National S	Stage			
Attachment(s)						
1) Notice of References Cited (PTO-892)	4) Interview S	Summary (PTO-413)				
 Notice of Draftsperson's Patent Drawing Review (PTO-948 Information Disclosure Statement(s) (PTO-1449 or PTO/SE Paper No(s)/Mail Date 	·	s)/Mail Date nformal Patent Application (PTO	152)			

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on Feb 4, 2004 has been entered and fully considered.

Claim Objections

Claim 12 is objected to because of the following informalities: "c nfigured" and "th" seem to by typos. Appropriate correction is required.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-3, 5, 12 and 14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hasegawa in view of Ishikawa et al. (Ishikawa).

Hasegawa discloses an apparatus and a method of scribing a semiconductor wager, comprising imaging the wafer (1101) through a layer of opaque layer (115); generating a picture of the wafer from the image of the wafer using an infrared camera (1211), the picture identifying the scribe lines under the opaque material (para 0110); and scribing the wafer with a dicing

device to singulate individual die on the wafer (para 0110-0111). However, Hasegawa does not discloses a computer for generating and mapping the coordinates of the scribe lines. Ishikawa discloses generating a picture of a wafer from the image and a computer using the picture to identify the scribe lines and scribing the wafer using the lines and dicing the wafer using the scribe lines (col. 3, lines 30-67). Therefore, it would have been obvious to one of ordinary skill in the art at the time of invention to provide the computer of Ishikawa to the invention of Hasegawa in order to obtain chips with accuracy and reduction of damage as taught by Ishikawa in col. 1, lines 41-45.

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Claims 6-8 and 13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hasegawa in view of Ishikawa et al. as applied to claim 1 above, and further in view of Walker et al. (Walker).

The further difference between the claimed invention and the modified Hasegawa is the heating of the wafer to predetermined temperature wherein the predetermined temperature is approximately 90 degrees C or less. Walker also teaches heating the wafer to predetermined temperature of approximately 90 degrees C or less (col. 8, lines 47-57). Therefore, it would have been obvious to one of ordinary skill in the art at the time of invention to further provide the method of heating and a temperature controller for heating the wafer to a predetermined temperature to the invention of Hasegawa in order to pre-cure and evaporate solvents as taught by Walker in col. 8, lines 50-55.

Claims 10 and 15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ishikawa in view of Ueta (6,590,919).

The further difference between the claimed invention and the modified Hasegawa is using X-rays to image the wafer. Ueta discloses using x-ray to image the wafer and to divide the wafer into chips by scribing (col. 6, line 39 – col. 7, line 44). Therefore, it would have been obvious to one of ordinary skill in the art at the time of invention to further provide another means to image the wafer where infrared camera imaging is in appropriate as taught by Ueta in col. 6, lines 39-65.

Claims 11 and 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ishikawa in view of Hahn et al. (Hahn) (6,131,880).

The further difference between the claimed invention and the modified Hasegawa is using ultrasound to image the wafer. Hahn discloses using ultrasound to image and scribe the wafer (col. 10, lines 1-12). Therefore, it would have been obvious to one of ordinary skill in the art at the time of invention to further provide another means to image the wafer where infrared camera imaging is in appropriate as taught by Hahn in col. 10, lines 1-12.

Remarks

Applicant argues that Ishikawa teaches away from the present invention. However,

Ishikawa is relied only for the use of computer to generate image and identify the scribe lines.

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Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Peter Kim whose telephone number is (571) 272-2120. The examiner can normally be reached on Monday-Thursday from 8:30 AM to 6:00 PM. The examiner can also be reached on alternate Fridays during the same hours.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Russ Adams can be reached on 571-272-2112. The fax phone numbers for the organization where this application or proceeding is assigned is 703 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 571 –272-2800.

Peter B. Kim
Patent Examiner

March 22, 2004